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S/N 10/757,864

PATENTIN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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|-------------|---|-----------------|----------------|
| Applicant: | KITAOKA ET AL. | Examiner: | SONG |
| Serial No.: | 10/757,864 | Group Art Unit: | 1722 |
| Filed: | JANUARY 15, 2004 | Docket No.: | 10873.1391US01 |
| Title: | METHOD OF MANUFACTURING GROUP III NITRIDE SUBSTRATE AND SEMICONDUCTOR DEVICE | | |

CERTIFICATE UNDER 37 CFR 1.6(d): I hereby certify that this paper is being transmitted by facsimile to the U.S. Patent and Trademark Office on April 7, 2006.

By: 

Name: Gina M. Dahl

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Applicants elect Group I (claims 1-5, 18 and 19) in response to the Restriction Requirement of March 21, 2006.

Applicants traverse the requirement to the extent of requesting that claims in Group II that correspond to allowable Group I claims be reinstated for allowance. An early and favorable action on the merits is requested.

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PATENT

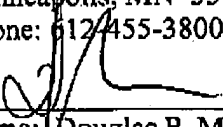
Please charge any additional fees or credit any overpayment to Deposit Account

No. 50-3478.

Respectfully submitted,

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Date: April 7, 2006

By 
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